



PATENT
52201-0632

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants : Yasuo Ohama et al.
Serial No. : 10/523,319
Filed : January 31, 2005
For : QUARTZ GLASS CRUCIBLE FOR PULLING UP SILICON
SINGLE CRYSTAL AND METHOD FOR PRODUCING THE
SAME
Art Unit : 1731
Examiner : Jason L. Lazorcik

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Mail Stop Issue Fee, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on: February 3, 2010.

Andrew L. Tiajloff
Name of Applicant, Assignee
or Registered Representative


Signature

February 3, 2010
Date of Signature

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Commissioner for Patents
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Alexandria, VA 22313-1450

COMMENT ON THE EXAMINER'S REASONS FOR ALLOWANCE

Sir:

Applicant wishes to comment on the Examiner's two assertions in the reasons for allowability. In the Notice of Allowability at page 4, the Examiner wrote the following:

Applicant finally acknowledges the Official position that 1) it would have been obvious to replace the transparent quartz layer of **Nakajima** with the transparent synthetic quartz layer of **Matsumura** and 2) to replace the opaque layer of **Nakajima** with the opaque natural quartz layer of **Matsumura**.

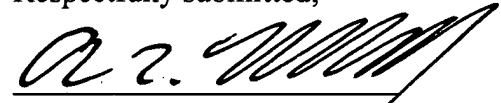
In fact, at no time did Applicant acknowledge either of these two assertions. Nakajima teaches a crucible made entirely of one type of quartz glass material, part of which is treated to be transparent and part of which is treated to be opaque. There is nothing in Nakajima that suggests substituting different materials in different parts of the crucible, nor does Matsumura suggest substitution of synthetic quartz glass for the transparent quartz layer of Nakajima.

For the foregoing reasons, applicant disagrees with and objects to the Examiner's reasons for allowability.

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Respectfully submitted,


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